

Docket No.: 01641/0204258-US0
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Karl-Heinz SCHUSTER et al.

Application No.: 10/596,626

Confirmation No.: 8534

Filed: September 15, 2006

Art Unit: 2873

For: MICROLITHOGRAPHY PROJECTION
OBJECTIVE WITH CRYSTAL LENS

Examiner: E. A. Lester

SUPPLEMENTAL RESPONSE TO NON-FINAL OFFICE ACTION

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INTRODUCTORY COMMENTS

Dear Sir:

In response to the Office Action dated April 15, 2009, and in conjunction with the Response file June 23, 2009, please consider the following remarks:

Remarks/Arguments begin on page 2 of this paper